

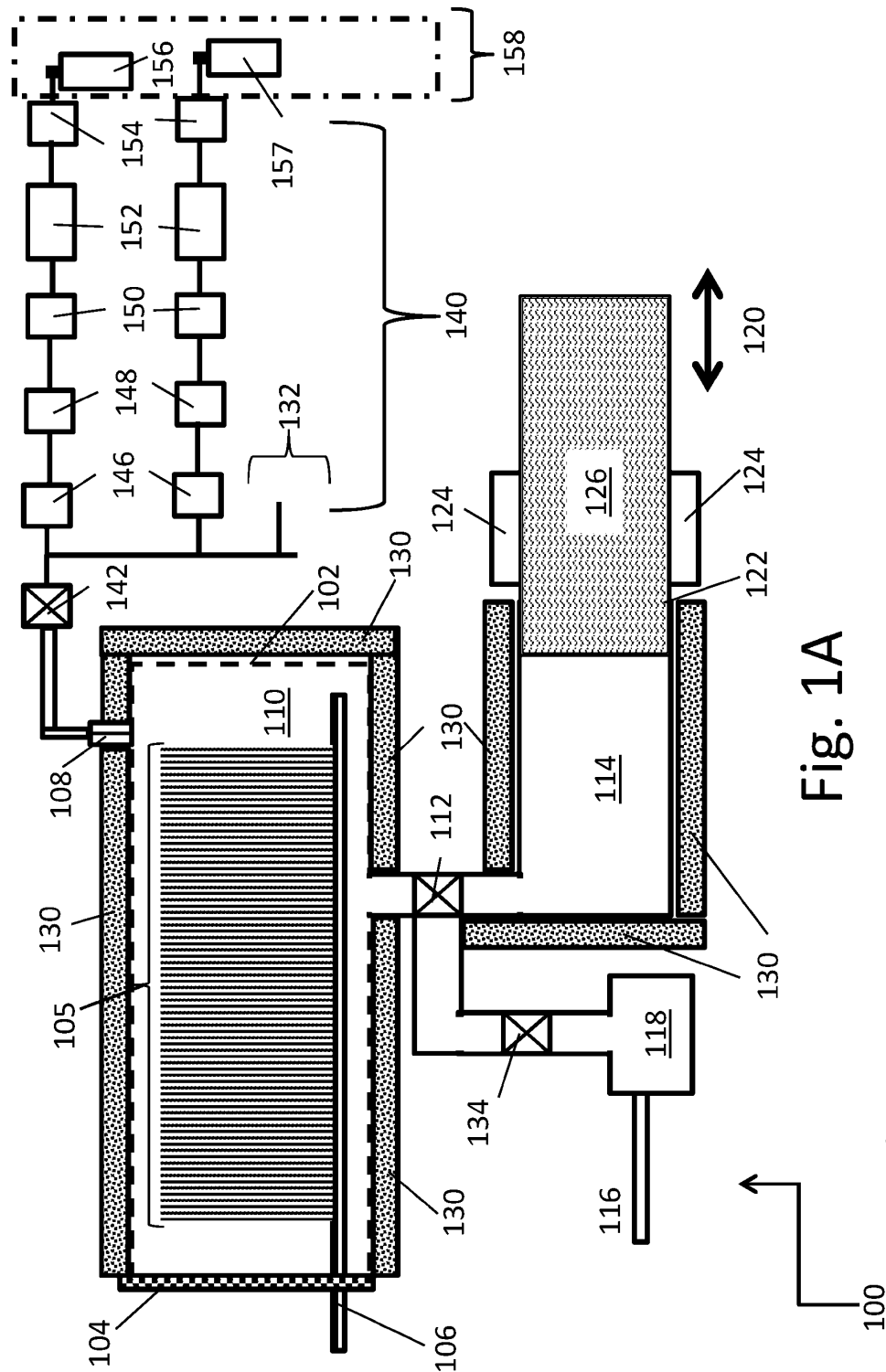


Fig. 1A

Batch/single; Dopant = gaseous; substrate pressurization = gaseous

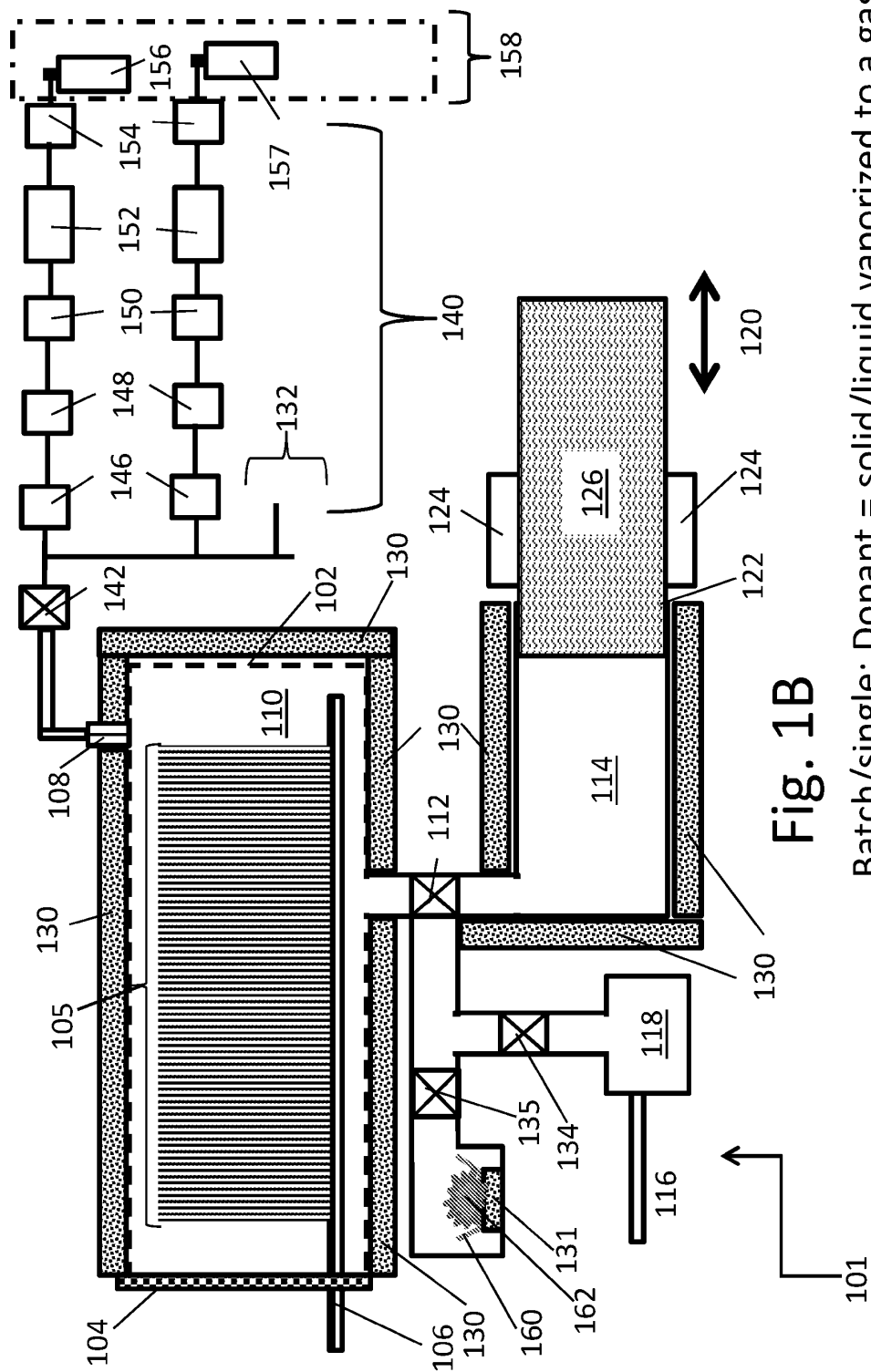


Fig. 1B

Batch/single; Dopant = solid/liquid vaporized to a gas;
substrate pressurization = gaseous

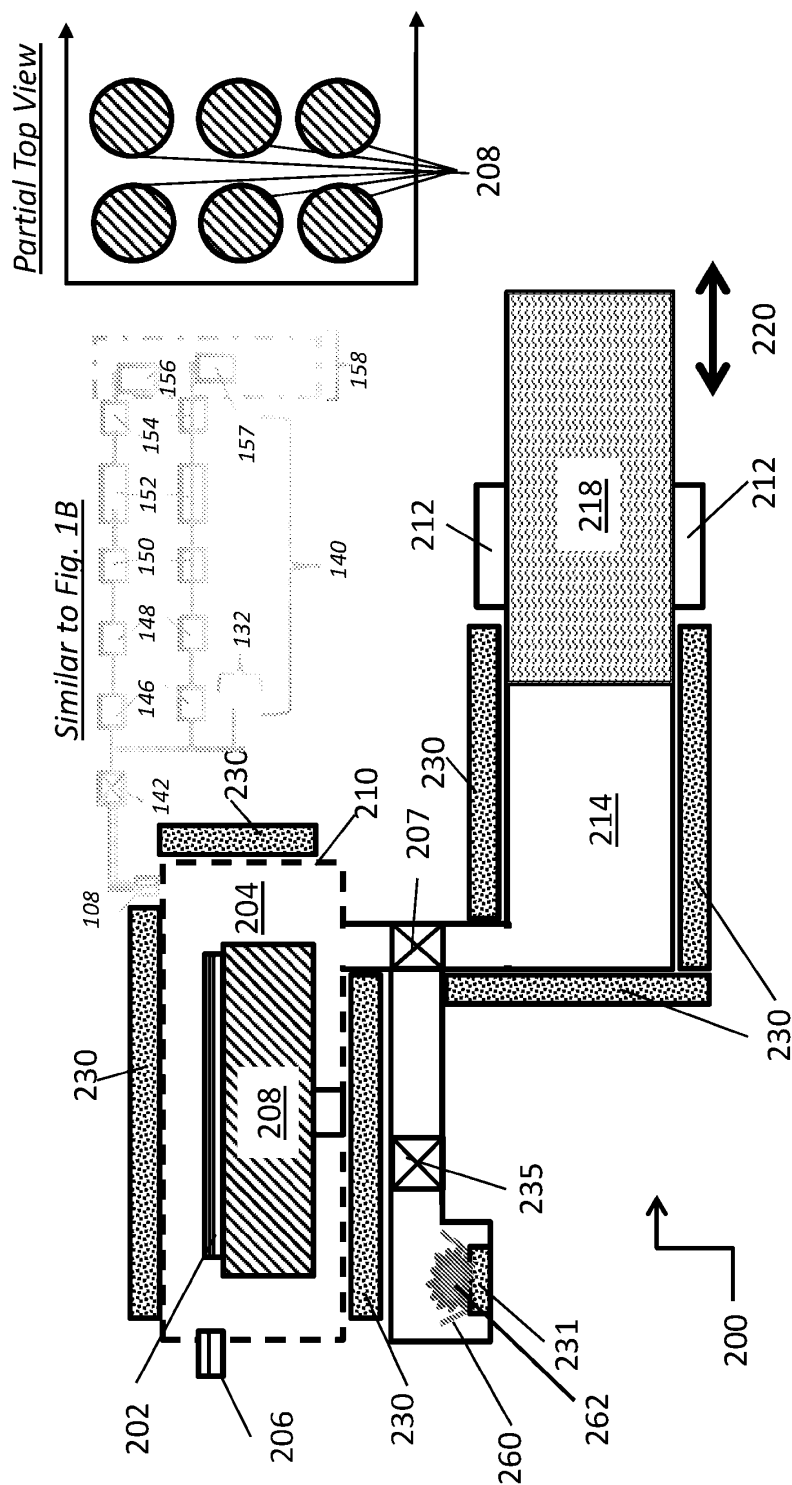


Fig. 2

Platen-Single/multi; Dopant = solid/liquid vaporized to a gas; substrate pressurization = gaseous

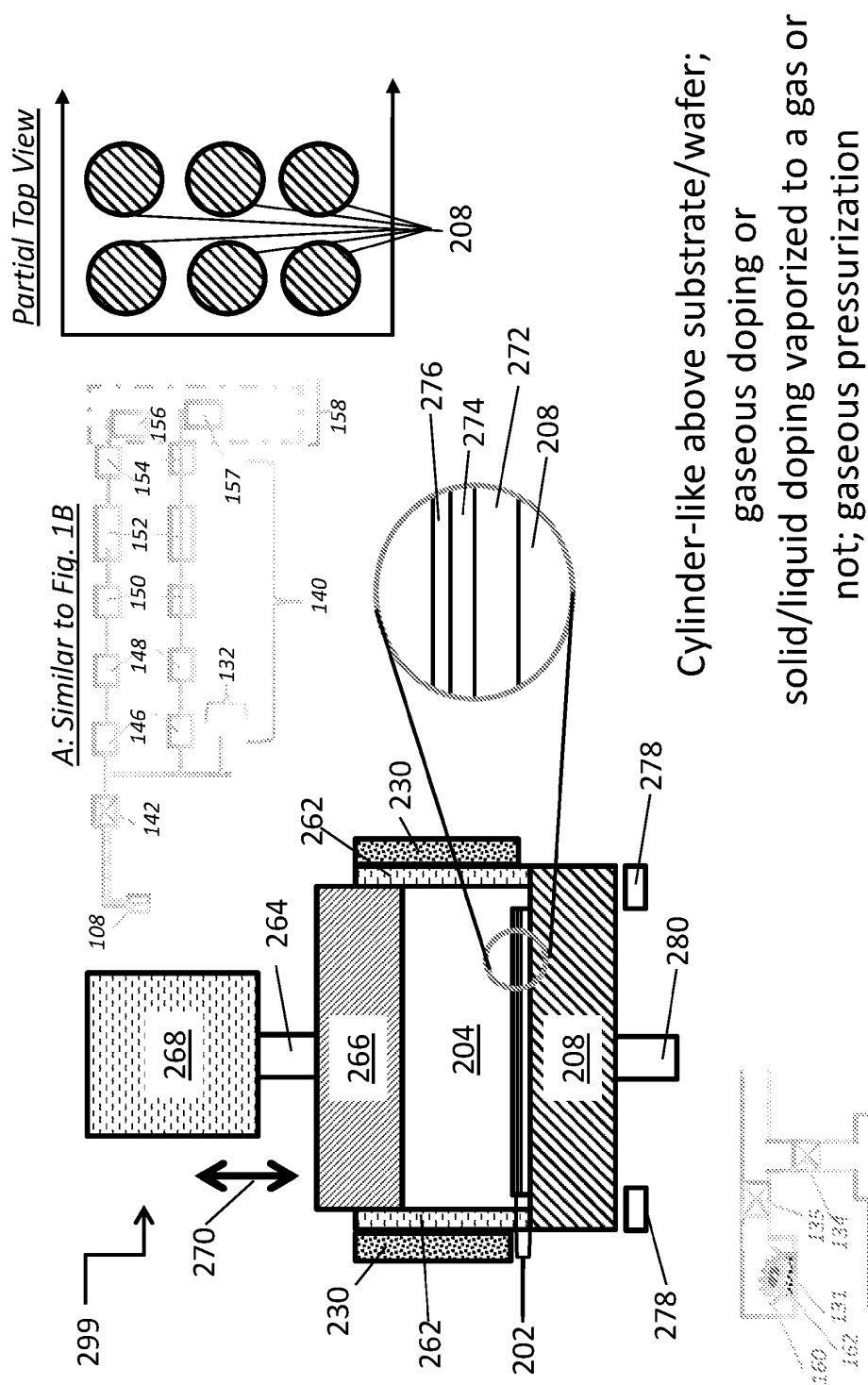


Fig. 2A

B: Similar to Fig. 1B

